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Mueni

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Cabral, Jr. et al.

Serial No.: 09/902,483

Group Art Unit: 2813

Filing Date: July 11, 2001

Examiner: Erik Kielin

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TECHNOLOGY CENTER 2800

For: SELF-ALIGNED SILICIDE (SALICIDE) PROCESS FOR LOW RESISTIVITY
CONTACTS TO THIN FILM SILICIDE-ON-INSULATOR AND BULK MOSFETS
AND FOR SHALLOW JUNCTIONS

Assistant Commissioner of Patents
Washington, D.C. 20231

SUBMISSION OF PROPOSED DRAWING CORRECTIONS

Sir:

Submitted herewith are proposed drawing corrections, marked in red, to Figures 1-6. If approved, such corrections will be incorporated into the formal drawings at the time of allowance.

Approval and acknowledgment of receipt are respectfully requested.

Respectfully submitted,

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Date: May 14, 2002
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